

ENTHALPY MODEL FOR HEATING, MELTING, AND VAPORIZATION IN LASER ABLATION

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ABSTRACT. Laser ablation is used in a growing number of applications in various areas including medicine, archaeology, chemistry, environmental and materials sciences. In this work the heat transfer and phase change phenomena during nanosecond laser ablation of a copper (Cu) target in a helium (He) background gas at atmospheric pressure are presented. An enthalpy model is outlined, which accounts for heating, melting, and vaporization of the target. As far as we know, this is the first model that connects the thermodynamics and underlying kinetics of this challenging phase change problem in a self-consistent way.

1. INTRODUCTION

Laser ablation (LA) is the process of removing material from a target using a laser beam. It is used in a growing number of applications, such as pulsed laser deposition, nanoparticle manufacturing, micromachining, surgery, as well as chemical analysis [30, 32, 11].

Direct solid microanalysis using LA in combination with inductively coupled plasma mass spectrometry (LA-ICP-MS) is nowadays one of the most frequently used techniques for a fast and powerful multi-element determination of solid samples at the trace and ultra-trace concentration levels of a wide variety of sample types [31, 8, 4, 14].

The growing interest in LA as a sample introduction technique stems from the ability to sample diverse materials, ranging from conducting to non-conducting, inorganic and organic compounds as solids or powders. Besides bulk analysis, the focussing characteristics of lasers permit sampling in small areas, so that localized microanalysis and spatially resolved studies become feasible. The processes occurring during LA-ICP-MS are depicted schematically in Fig. 1.

2000 *Mathematics Subject Classification.* 92C45, 35K60, 65M99.

Key words and phrases. Laser ablation; phase change; enthalpy scheme; thermochemistry; finite volume scheme.

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Published September 25, 2010.

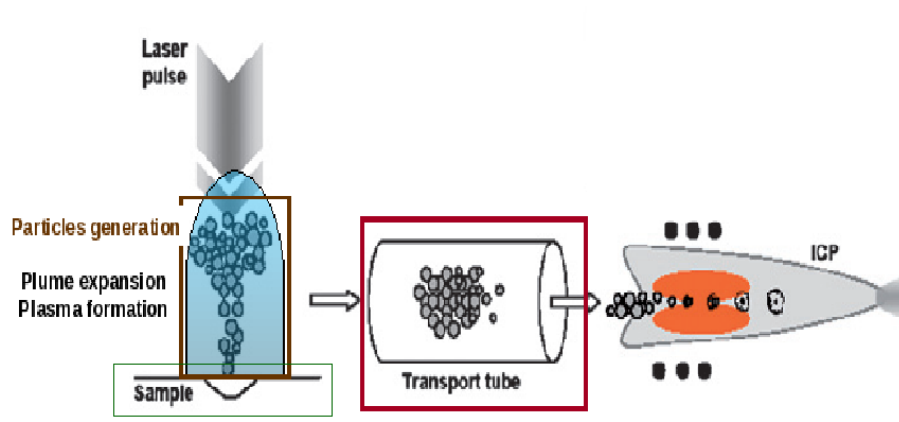


FIGURE 1. Schematic of the Laser Ablation - Inductively Coupled Plasma Mass Spectrometry (LA-ICP-MS) process. (Courtesy of C.C. Garcia, ISAS, Dortmund)

Within an ablation cell, an amount of matter is extracted from the sample by focusing a laser beam on its surface. The sample heats up, melts, vaporizes, and expands against a carrier gas at atmospheric pressure. The expanding plume partially ionizes under the laser radiation and a plasma is generated above the target. Complex physical processes occurring at the target surface and in the expanding plume result in the formation of small particles with sizes ranging from several nanometers to a few micrometers. The aerosol is subsequently transported by the carrier gas through a tubing system to an ICP-torch where it is ionized. Finally a small fraction of the ions is sent to the MS-instrumentation where they are analyzed.

The laser ablation process is typically investigated by means of kinetic [28, 12, 18, 13, 24], hydrodynamic [7, 9, 15, 5, 26], or hybrid models [19, 20]. Because kinetic and hybrid models require quite long calculation times, one tries to apply hydrodynamic models if at all possible. Since the laser-target heating during LA-ICP-MS results in a cascade of complex physical processes (see §2), it is of utmost importance to include in the existing hydrodynamical models a consistent treatment of target heating. Here the kinetic relations that interconnect the physical processes in and above the target determine the pathway the metal follows on the phase diagram during laser heating. Accordingly, one has to account for them in order to arrive at a physically consistent treatment of laser-material interaction.

In §2 we briefly describe some issues that arise during the modeling of *nanosecond laser ablation*. In §3 we describe a seamless enthalpy-based model treating the heating, melting and vaporization of the target. Numerical simulations for laser ablation of copper (Cu) in a background gas (He) in 1-D, are presented in §4, and final conclusions in §5.

2. NANOSECOND LASER ABLATION

Several complex, tightly coupled physical processes occur in and just above the target. The target heats up, melts and vaporizes. Above the target, the evaporated particles achieve translational equilibrium within a few mean free paths by means of collisions. This transition layer is known as the *Knudsen layer* (KL). The vapor near

the target is a partially ionized gas that is separated from the surface by an electrical sheath across which there is a potential drop that accelerates the charged particles. The Knudsen layer provides the connection between the ‘inner world’ (target) and the ‘outer world’ (plasma plume). Beyond this layer, the plasma absorbs laser energy before it can reach the target, giving rise to plasma shielding. The absorption of laser energy results in very high plume temperatures, velocities, species densities, pressures, and so on. At later times, small particulates are formed during the cooling stage of the plume. Here homogenous nucleation and recondensation result in nanosized particles. Moreover, recoil pressures acting on the melt can cause melt motion and melt expulsion forming larger particles. The melt pool dynamics leads to formation of jets at the edge of the formed crater, that break up in microdroplets [32, 6]. An effective hydrodynamic model of the entire ablation process should possess the following highly desirable features:

- seamless treatment of heating / melting / vaporization,
- temperature-dependent thermophysical and optical properties,
- treatment of vapor as a non-ideal gas by means of an equation of state(EOS) up to and above the critical temperature T_{crit} ,
- treatment of the plasma-sheet at the target surface,
- coupling target and plume by means of the Knudsen layer,
- treatment of plume expansion and recondensation, in vacuum or in a background gas
- dealing with plasma formation (ions and electrons) mechanisms,
- treating absorption of laser energy in the plume and shielding of the target,
- capturing (very) strong shocks via high resolution numerical schemes,
- be applicable in 1D, 2D axisymmetric and 3D spatial dimensions.

Additional challenges in modeling laser ablation arise from:

- extreme space and time scales,
- extreme gradients: temperature may rise to thousands of degrees locally,
- extreme variation in thermophysical properties,
- the need for extensive thermophysical data: T-dependent density, heat capacity, thermal conductivity, phase diagram for solid, liquid, vapor over the range 300 K to T_{crit} (~ 8000 K),
- the need for T-dependent and wavelength dependent optical data.

3. ENTHALPY MODEL FOR TARGET HEATING - MELTING - VAPORIZATION

In this section we develop an enthalpy formulation for target heating - melting - vaporization which addresses the issues listed above.

Heat conduction and phase changes in the target are naturally described by the energy conservation law in terms of the (volumetric) enthalpy H .

$$\partial_t H + \nabla \cdot \vec{Q} = S. \quad (3.1)$$

The laser source term S , at time t and position z , is given by

$$S(t, z) = I(t)(1 - R) \alpha e^{-\alpha z}, \quad (3.2)$$

with R and α the reflection and absorption coefficients of the target, respectively, and intensity

$$I(t) = \beta I_o e^{-(t-t_{max})^2/2\sigma^2}. \quad (3.3)$$

Here β is the shielding coefficient at the target that depends on the plume temperature and species densities (neutrals, ions and electrons) above the target. The calculations presented later in §4 are performed for a Gaussian-shaped laser pulse of full width at half maximum (FWHM) 10 ns, and peak laser intensity of the order of 10^{13} W/m^2 , at a wavelength of 266 nm. In Fig. 3 the laser intensities before ($\beta = 1$) and after shielding at the surface are shown.

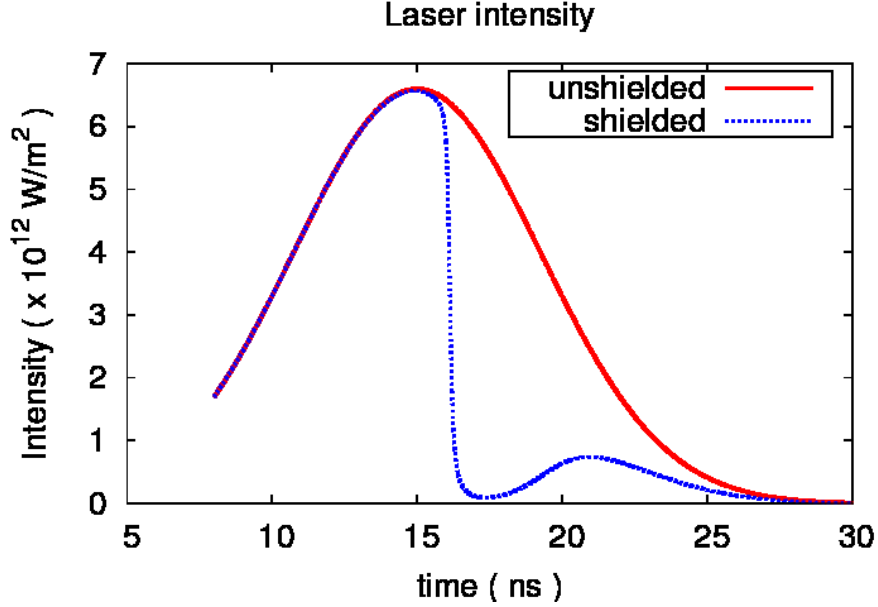


FIGURE 2. Time course $I(t)$ of laser pulse intensity with FWHM=10 ns, peak $7 \times 10^{12} \text{ W/m}^2$.

There are three time scales that characterize laser heating: $\tau_e = C_e/\gamma$, the electron cooling time, $\tau_i = C_i/\gamma$, the lattice heating time, and τ_l , the duration of laser pulse. Here C_e and C_i are the heat capacities of the lattice and the electron subsystems, respectively, and γ a parameter characterizing the electron-lattice coupling in the target. Since τ_e is of the order of 1 ps and τ_l is of the order of ns, the electron absorbed energy has enough time to be transferred to the lattice [10]. Consequently, the electrons and the lattice reach thermal equilibrium and heat conduction in the target can be described by means of Fourier's law provided that the heat flux is constant over several mean free paths of the electrons that carry the heat [17]. Since the melt thickness is very small, convective effects do not arise in the melt. Thus the heat flux in the solid and liquid is due to heat conduction only, $\vec{Q} = -k\nabla T$, with k = thermal conductivity, T = temperature. On the contrary, the presence of strong advection in the plume domain requires solution of the continuity and momentum equations as well.

Note that, depending on the local pressure P , vaporization can occur at any temperature above absolute zero, even below the melt point T_m as well as above the normal boiling point T_b . Therefore the vaporization temperature $T_V(P)$ is unknown and must be determined in the course of the solution. Finally note that

the surface recession velocity, which determines the crater depth in the target, is also an unknown, since the surface is an unknown moving boundary.

The energy conservation law (3) is valid mathematically, in the weak sense, throughout the system irrespective of phase (with coefficients appropriate to phase: k^S , k^L , k^V , etc.). It directly updates the enthalpy H (per unit volume) to new times, from which we need to find the new phase, temperature, and phase fractions. This requires Equations of State (EOS) $H = H(T, P, \text{phase})$ consistent with the thermochemistry of the material, which we describe below.

3.1. Phases from volumetric enthalpy. The development is based on the basic Gibbs relation for the exact differential of enthalpy [1] in any phase $i = S, L, V$:

$$dH^i = C_p^i dT + [-\alpha^i T + 1]dP \quad i = S, L, V, \quad (3.4)$$

where C_p^i and α^i are the heat capacity (per unit volume) and thermal expansion coefficient of phase i , respectively. The enthalpy within each phase (Solid, Liquid, Vapor) can be expressed in terms of the pair (T, P) by integration along constant T and constant P paths on the (T, P) -phase diagram, of the Gibbs relation (3.1), relative to a *consistent* reference state.

In what follows, upper case H denotes volumetric enthalpy (per unit volume), lower case h denotes specific enthalpy (per unit mass), and values with subscript "o" denote interfacial (switch) values. Clearly, $H = \rho h$ in each phase. We are dealing with three phases: solid (S), liquid (L), vapor (V). The amount of phase $i = S, L, V$ present can be quantified by its *volume* phase fraction, Λ^i , or by its *mass* phase fraction, λ^i . The fractions are related by: $\rho^i \Lambda^i = \rho \lambda^i$ ($i = S, L, V$), where ρ = total density (of mixture) = $\sum_i \rho^i \Lambda^i$. Note that fractions must add up to 1: $\Lambda^S + \Lambda^L + \Lambda^V = 1$ and $\lambda^S + \lambda^L + \lambda^V = 1$. For simplicity, we assume the density of solid, ρ^S , and of liquid, ρ^L , remain constant (but $\rho^S \neq \rho^L$).

As reference state we choose *solid* at temperature T_m and pressure $P_{\text{ref}} = 1$ atm. The value h_{ref} (and thus also $H_{\text{ref}} = \rho^S h_{\text{ref}}$) of the enthalpy at the reference state can be arbitrary; it will be chosen later (so as to make $\Delta H^{vap} > 0$). By integration of (3.1) within each phase, and changing phase at (T_m, P_{ref}) (from solid to liquid) and at (T_V, P_{ref}) (from liquid to vapor) we can characterize the phases in terms of the value of H alone (which is being updated by the energy conservation law). This is done in terms of certain *switch* values H_o^S , H_o^L , $H_o^{LV}(T_V)$, and $H_o^V(T_V)$, defined below, with T_V any desired vaporization temperature ($T_m < T_V \leq T_b$).

- **Solid phase** ($T \leq T_m$): $H < \mathbf{H}_o^S := H_{\text{ref}} \equiv \rho^S h_o^S$, (set $h_o^S := h_{\text{ref}}$).

$$\text{Then } \Lambda^S = 1, \Lambda^L = 0, \Lambda^V = 0, \rho = \rho^S, \quad H(T) = H_o^S + \int_{T_m}^T C_p^S(\tau) d\tau.$$

Thus, given H , we can find the temperature T ($< T_m$) by solving the equation:

$$\int_{T_m}^T C_p^S(\tau) d\tau = H - H_o^S \quad \text{for } T.$$

- **Solid-Liquid transition** (at $T = T_m$): $\mathbf{H}_o^S < H < \mathbf{H}_o^L := \rho^L h_o^L$, with $h_o^L = h_o^S + \Delta h^{fus}$. Set $\Delta H^{fus} := H_o^L - H_o^S \equiv (\rho^L - \rho^S) h_o^S + \rho^L \Delta h^{fus}$, which can be made > 0 by choosing h_{ref} to be ≤ 0 .

$$\text{Then } T = T_m, \quad \Lambda^L = (H - H_o^L) / \Delta H^{fus}, \Lambda^S = 1 - \Lambda^L, \Lambda^V = 0, \\ \rho = \Lambda^S \rho^S + \Lambda^L \rho^L, H = H_o^L + \Lambda^L \Delta H^{fus}, h = H / \rho.$$

- **Liquid phase** ($T_m < T < T_V$): $\mathbf{H}_o^L < H < \mathbf{H}_o^{LV}(T_V) := H_o^L + \int_{T_m}^{T_V} C_p^L(\tau) d\tau$.

$$\text{Then } \Lambda^L = 1, \Lambda^S = 0, \Lambda^V = 0, \rho = \rho^L, H(T) = H_o^L + \int_{T_m}^T C_p^L(\tau) d\tau.$$

Thus, given H , we can find the temperature T ($T_m < T < T_V$) by solving for T the equation: $\int_{T_m}^T C_p^L(\tau) d\tau = H - H_o^L$.

• **Liquid-Vapor transition** (at $T = T_V$): $\mathbf{H}_o^{LV}(\mathbf{T}_V) < H < \mathbf{H}_o^V(\mathbf{T}_V, \mathbf{P}_{\text{ref}}) := \rho^V(T_V, P_{\text{ref}})h_o^V$, with $h_o^V(T_V, P_{\text{ref}}) := h_o^{LV}(T_V) + \Delta h^{vap}(T_V, P_{\text{ref}})$, where $\rho^V(T_V, P_{\text{ref}})$ = vapor density at (T_V, P_{ref}) , and $\Delta h^{vap}(T_V, P_{\text{ref}})$ = heat of vaporization at (T_V, P_{ref}) . Set $\Delta H^{vap} := H_o^V - H_o^{LV} \equiv (\rho^V - \rho^L)h_o^{LV}(T_V) + \rho^V \Delta h^{vap}(T_V, P_{\text{ref}})$, which can be made > 0 for any $T_m < T < T_{\text{crit}}$ by choosing h_{ref} sufficiently negative, namely $h_{\text{ref}} < -\Delta h^{fus} - c_p^L [T_{\text{crit}} - T_m]$, thanks to the fact that $\Delta h^{vap}(T_{\text{crit}}) = 0$.

Then $\Lambda^V = (H - H_o^{LV})/\Delta H^{vap}$, $\Lambda^L = 1 - \Lambda^V$, $\Lambda^S = 0$, $\rho = \Lambda^L \rho^L + \Lambda^V \rho^V$,
 $H = \rho h = H_o^{LV}(T_V) + \Lambda^V \Delta H^{vap}$, $h = H/\rho$.

• **Vapor phase** ($T > T_V$): $H > \mathbf{H}_o^V(\mathbf{T}_V, \mathbf{P}_{\text{ref}})$.

Then $\Lambda^V = 1$, $\Lambda^L = 0$, $\Lambda^S = 0$,

$$H(T, P) = H_o^{LV}(T_V) + \int_{T_V}^T C_p^V(\tau, P_{\text{ref}}) d\tau + \int_{P_{\text{ref}}}^P [-T\alpha^V(T, p) + 1] dp,$$

with α^V the thermal expansion coefficient of vapor.

Since the heat capacity is strictly positive and ΔH^{fus} and ΔH^{vap} are also positive (by our choice of h_{ref}), the dependence of H on T is monotonic, as shown schematically in Fig. 3.1. Thus T can be found from H .

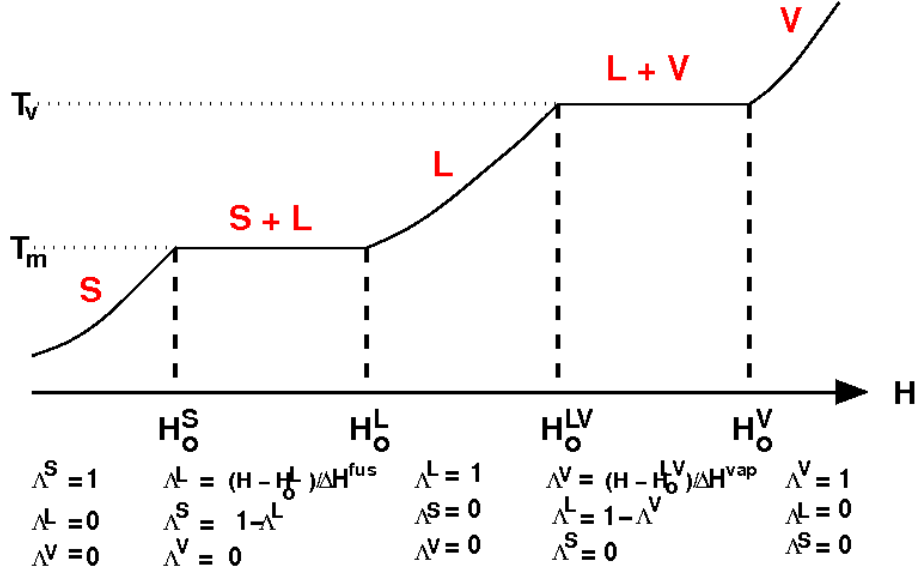


FIGURE 3. Schematic dependence of temperature T and phase fractions on volumetric enthalpy H .

The PDE (3) is discretized by a finite volume method, and explicitly in time. Briefly, the enthalpy algorithm proceeds as follows: Knowing the values of T and phase fractions at time step t_n , we evaluate the thermophysical property values, compute the flux $\bar{Q}$, and update the enthalpy H from the discretized PDE to time t_{n+1} . From H we find the phase indicators $\mathbf{H}_o^S$, $\mathbf{H}_o^L$, $\mathbf{H}_o^{LV}$, $\mathbf{H}_o^V$, which determine the temperature and phase fractions as described above.

3.2. Knudsen Layer and Vaporization temperature. Whereas melting occurs at a known melt temperature T_m ($= 1358$ K for copper), vaporization can occur at any temperature T_V , up to the critical temperature T_{crit} (~ 8000 K for copper), and must be determined at each time step. T_V depends on the pressure above the melt, which is coupled to the Knudsen layer.

Across the Knudsen Layer, treated as a gas dynamic discontinuity (shock), conservation of mass, momentum and energy impose certain jump conditions on temperature, pressure, density, and velocity.

There is extensive literature on modeling the Knudsen layer, at various scales and levels of detail, e.g. [2, 34, 22, 23, 27, 29, 12, 16, 15]. A useful treatment is given in Gusarov-Smurov [16]. Contrary to most earlier works, their treatment accounts for evaporation into a background gas. Moreover, it considers condensation back to the target, occurring when the outer pressure exceeds the surface pressure. The KL relations couple the target and plume, and the pressure ratio across the KL governs what happens at the melt surface.

Let T_V , P_V be the values at the melt surface (vaporization front), and T_{KL} , P_{KL} denote the values at the outer side of the Knudsen layer (away from the target, towards the plume). If the pressure ratio $P_{\text{ratio}} := P_{KL}/P_V < 1$ then subsonic evaporation occurs. If $P_{\text{ratio}} > 1$ then condensation occurs (vaporized material re-condenses onto the melt). Note that in case of ablation into vacuum one can assume sonic evaporation, in which case the pressure and temperature ratios over the KL are constant, resulting in the decoupling of the target and plume processes.

Every quantity experiencing a jump across the Knudsen layer is ultimately a function of the vaporization temperature T_V , which changes in time and needs to be evaluated at each timestep.

We have developed a new approach, based on enthalpy, that includes the underlying evaporation kinetics. The KL expressions from [16] are applied in an iterative procedure that determines T_V in a vaporizing control volume. An outline of the approach (too involved to present here in detail): is as follows: The updated enthalpy H detects if a control volume is vaporizing (if $\mathbf{H}_o^V(\mathbf{T}_V, \mathbf{P}_{\text{ref}}) < H < \mathbf{H}_o^V(\mathbf{T}_V, \mathbf{P}_{\text{ref}})$) at the current T_V . From the temperature T_{KL} , pressure P_{KL} , and gas density ρ^{KL} on the plume side, we find the recession velocity v_V of the vaporization front (by the Hertz-Knudsen relation and conservation of mass). From the recession velocity v_V we update the vapor fraction of the (control) volume Vol during a time-step Δt via $\Lambda^V = \Lambda_{old}^V + v_V Vol / \Delta t$. Then we estimate the new enthalpy of the volume as $H_{\text{new}}(T_V) = H_o^{LV}(T_V) + \Lambda^V \Delta H^{vap}(T_V)$, which should equal H . This constitutes an equation $H_{\text{new}}(T_V) = H$ for the unknown T_V , which we solve iteratively (by a bisection type root finder, such as Brent's algorithm).

Beyond the Knudsen layer, the plume of vapor expands rapidly and ionizes into plasma. The flow is modeled by the Euler equations of gas dynamics (plus species conservation for electrons, ions, neutrals, He gas), which must be solved simultaneously with the target since they are coupled at the Knudsen Layer. We employ finite volume discretization, explicit time-stepping, and a central 2nd order high resolution advection scheme. To save computational time, we use an adaptive grid in the plume which expands ahead of the plume.

Our numerical scheme allows temperature and pressure dependence of all thermophysical properties, and vapor properties from equations of state (such as [25] for copper).

4. NUMERICAL SIMULATIONS

We present 1-D simulations of laser ablation of Cu. The target is initially set at room temperature (300 K). Above the target we assume a stationary background gas (He), initially set at atmospheric pressure (1 atm) and room temperature (300 K). The entire system (target+background gas) is irradiated by a laser at the conditions mentioned in §3.

The target, of thickness $12\text{ }\mu\text{m}$, is discretized along the axial direction (direction of the laser beam), into a non-uniform grid of 2000 control volumes, denser near the surface. In the plume region we use (much) bigger cells, of length $\Delta z = 5 \times 10^{-7}\text{ m} = 500\text{ nm}$, the number of which is adaptively increased to extend the grid beyond the expanding plume. The time-step is taken to be $\Delta t = 1 \times 10^{-13}\text{ s}$, respecting the CFL condition in the entire computational domain. The total simulation time is 30 ns, which corresponds to a single pulse, cf. Fig. 3. Thermodynamic properties of Cu are obtained from the ITTEOS [25] EOS data (via interpolation).

As a result of the deposited laser energy the target heats up very fast. The time evolution of the melting and vaporization fronts is shown in Fig. 4. At 7.5 ns melting starts and vaporization is assumed to be minor. At 10 ns the first cell exceeds the normal boiling point ($T_b = 2835\text{ K}$) and vaporization becomes significant. Thus the vaporization (surface) temperature T_V and pressure P_V , as well as the pressure at the outer side of the KL, P_{KL} , increase quickly as seen in Fig. 4–4. Since $P_{KL} < P_V$ the evaporation is subsonic (see §3.2).

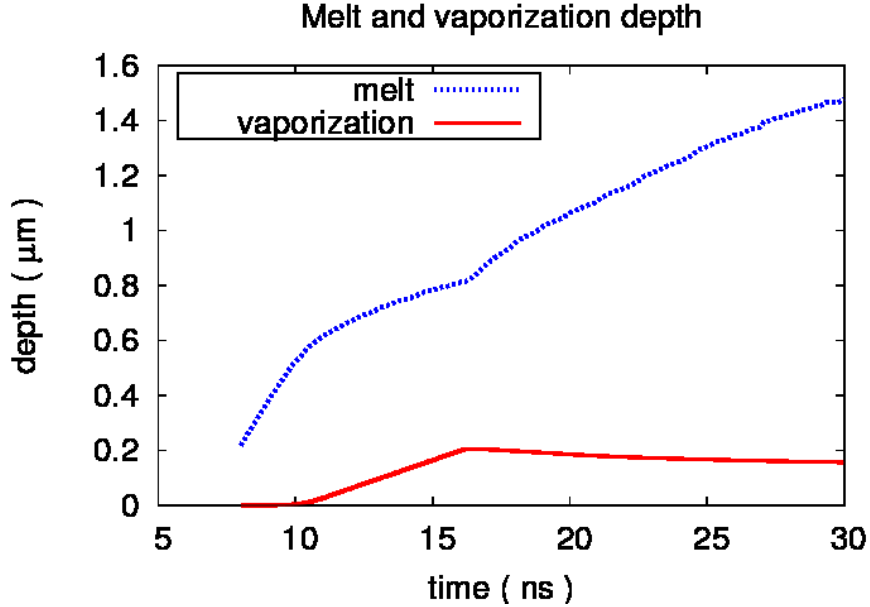


FIGURE 4. Melt and vaporization depths vs time.

When the surface reaches temperatures near the critical state, the melt becomes transparent. This bleaching of liquid properties occurs at temperatures about $0.9 T_{\text{crit}}$ [3], [21], [33]. Here a strong reduction of the electron density in

the liquid results in a drastic change of the optical properties. As the incident laser energy penetrates through this transparent layer to the underlying material, the transparency front starts to propagate into the interior liquid. The transparent surface cell now evaporates at a constant vaporization temperature $T_V \approx 0.9 T_{\text{crit}}$ as can be seen in Fig. 4.

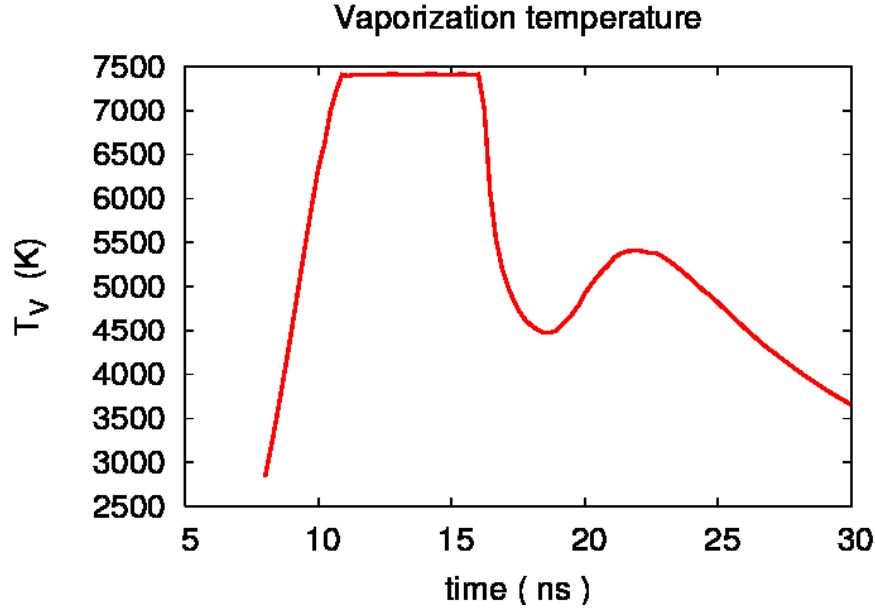


FIGURE 5. Vaporization temperature vs time.

In this hot dense plume, an amount of electrons is created due to photoionization of the excited atoms. These electrons absorb additional energy in, so called, inverse bremsstrahlung processes [35]. Due to the absorption of laser energy, additional electrons and ions are formed resulting in an avalanche effect that keeps on increasing the plume temperatures to a few 10000 K (here 30000 K): a plasma is created.

At a certain instant, here at ≈ 16 ns, the plasma is so dense that it completely shields the target. As a result, the vaporization temperature and pressure decrease, and when $P_V < P_{KL}$ we arrive at the condensation regime (Fig. 4). During this stage, vapor from the plume recondenses on the target, the recession velocity becomes negative (Fig. 4), and the crater depth decreases (4).

After a while, at ≈ 20 ns, the plume density above the target decreases due to advection, the laser light reaches again the target surface raising the surface temperature and pressure, and we return to the subsonic evaporation regime. Accordingly, the laser intensity profile at the target takes a bimodal shape (Fig. 3).

As the applied laser pulse diminishes toward the end, the amount of laser energy deposited in the plume decreases, the surface temperature and pressure decrease as well, and material recondenses on the surface. In the final stage evaporation and condensation compete, resulting in a recession rate of ≈ 0 and constant evaporation depth of ≈ 150 nm, as seen in Fig. 4 – 4.

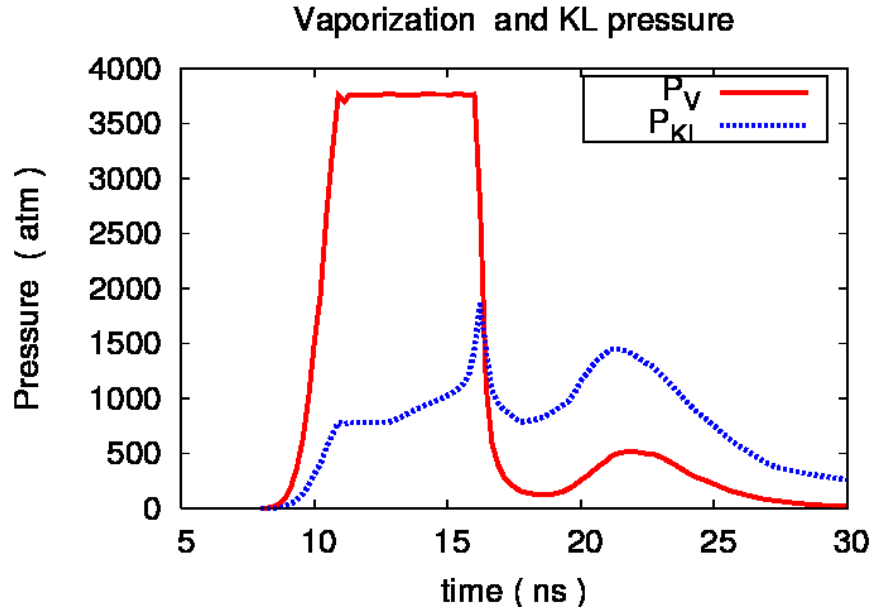


FIGURE 6. Vaporization (saturation) pressure P_V vs time, and pressure at the outer side of the Knudsen layer, P_{KL} , for comparison.

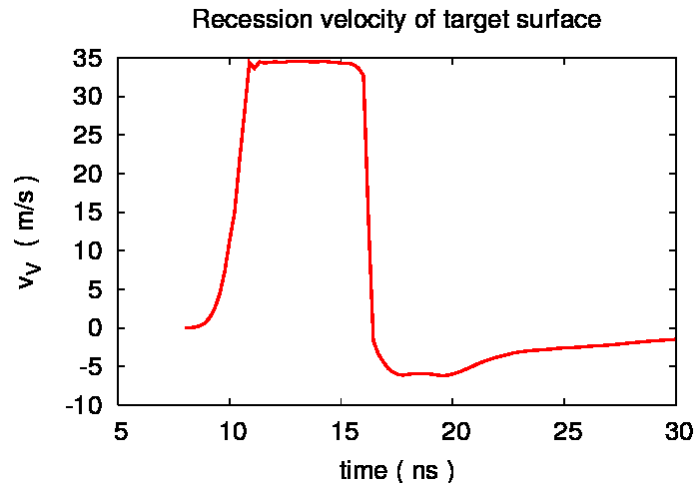


FIGURE 7. Vaporization (recession) velocity vs time.

5. CONCLUSION

A seamless enthalpy formulation of heat transfer and phase changes during nanosecond laser ablation of a target is presented.

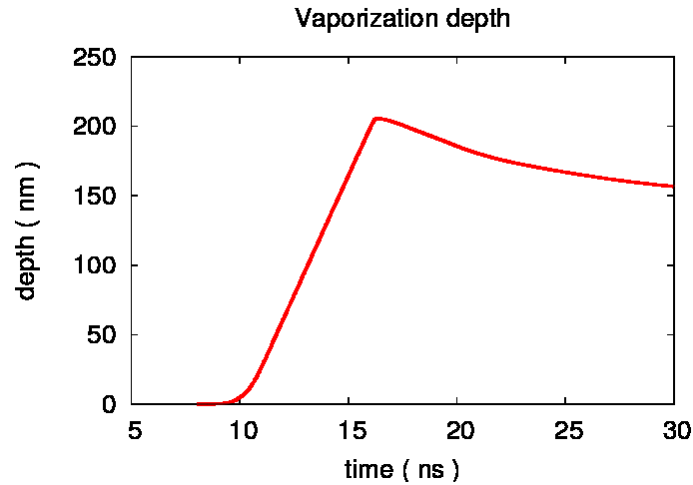


FIGURE 8. Vaporization depth vs time. Maximum depth reaches 200 nm shortly after 15 ns (when laser intensity peaks).

The formulation is based on Equations of State of the form $H = H(T, P, \text{phase})$ consistent with the thermochemistry of the material. It allows full temperature (and/or pressure) dependence of thermophysical and of optical properties, and can use available EOS data, up to critical temperature. Thus, it can realistically describe all the phases of real materials.

The enthalpy model tracks both the solid/liquid and liquid/vapor fronts and accounts for the kinetic relations at the liquid/vapor front (Knudsen layer) using an iterative procedure. It couples naturally to plasma dynamics models in the plume and the coupled model possesses all the desirable features listed in §2. Thus, the entire laser ablation process can be simulated, from heating of the target, to plasma formation and laser absorption, to the shielding effect of plasma on the target and recondensation. As far as we know, this is the first model that connects the thermodynamics and underlying kinetics of this challenging phase change problem in a self-consistent manner. Being dimension-independent, it is applicable in 1D, 2D, and 3D modeling of laser ablation.

As proof of principle, we presented a one-dimensional numerical implementation for laser ablation of a copper target in helium background gas at atmospheric pressure, coupled to a gas dynamics model in the plume (where electrons, ions, and He gas are tracked). As we saw in §4, the expected physical behavior of the system is captured very well.

Acknowledgements. We thank Drs. PR Levashov and KV Khishchenko for providing EOS data for Cu. We also thank C.C. Garcia of ISAS, Dortmund, for the drawing of the LA-ICP-MS-setup (Fig. 1). Support of the second author by the Flemish Fund for Scientific Research (FWO Vlaanderen) is gratefully acknowledged.

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